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**PATENT NUMBER and
ISSUE DATE**

U.S. UTILITY Patent Application

APPL NUM 10034788	FILING DATE 12/27/2001	CLASS 414	SUBCLASS 404	GAU 3652	EXAMINER <i>FOX</i>
**APPLICANTS: Farrell Curtis; Liu Dennis;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>			
Foreign priority claimed		<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO		
35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no	0437-A-269		
Verified and Acknowledged Examiners's initials					
TITLE : Bi-directional wafer transfer mechanism and method					
U.S. DEPT. OF COMM /PAT & TM-PTO-436L(R.v. 12-9)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER			Application Examiner		
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